Form PTO 1449 (Rev. 2-32) U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 034299-000610	Serial No. 10/519,012
Information Disclosure Statement by Applicant	Applicant: Cyril Guedj et al.	
(Use several sheets if necessary)	Filed: December 21, 2004	Group: ~~unknown~~ 2878

U.S. Patent Documents

Init.		Document No.	Date	Name	Class	Subclass	Filing Date
QL	A	5,682,037	10/28/97	de Cesare et al.			
QL	B	6,018,187	01/25/00	Theil et al.			
QL	C	6,114,739	09/05/00	Theil et al.			

Foreign Documents

							Translation	
Init.		Document No.	Date	Country	Class	Subclass	Yes	No
QL	D	0 726 605	06.02.96	Europe	H01L 31	103	X	
QL	E	1 050 907	02.05.00	Europe	H01L 27	146	X	

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

QL	F	Afanas'ev et al., "Photodetector structures based on amorphous hydrogenated silicon with nanocrystalline inclusions", December 2001, The Optical Society of America, J. Opt. Technol., Vol. 68, No. 12, pp 949-951.
	G	Chatterjee et al., "The origin of current gain under illumination in amorphous silicon *n-i-p-i-n* structures", February 15, 2000, Journal of Applied Physics, Vol. 87, No. 4, pp. 1874-1881.
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	I	Morral, et al. "In situ investigation of polymorphous silicon deposition", 2000, Journal of Non-Crystalline Solids 266-269, pp. 48-53.
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Examiner /Que Tan Le/	Date Considered 10/24/2006

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